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SPECIAL-SHAPED EMOSS, MANUFACTURING METHOD OF SAME, AND SHOES
HAVING EMOSS

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[There are no amendments to this patent.]

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Claims

1. A type of special-shaped emboss characterized by the fact that for an emboss formed on a sole, the entirety of the ground-touching surface of said emboss is formed in a recess, and the peripheral portion of said ground-touching surface is formed at an acute angle with respect to the side surface of said emboss.

2. A method for manufacturing a special-shaped emboss characterized by the following facts: a surface of a perforated plate is pressed onto a base sheet, while an emboss liquid feed material is fed to flow into the holes of said perforated plate from the other side of said perforated plate; then, by means of a squeezing treatment, the liquid surface of the emboss liquid feed material in the holes on the other side of said perforated plate is formed into a concave shape; then, the emboss liquid feed material is cured, and the plate is removed.

3. A shoe type having a special-shaped emboss characterized by the fact that the shoes have an emboss in the sole, with the entirety of the ground-touching surface of the emboss formed in a recess, and with the peripheral portion of said ground-touching surface formed at acute angle with respect to the side surface of said emboss.

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